



Docket No.: SON-3163
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Tomiji Tanaka et al.

Application No.: 10/579,903

Confirmation No.: 6919

Filed: November 15, 2006

Art Unit: 2828

For: EXTERNAL CAVITY TYPE
SEMICONDUCTOR LASER

Examiner: Michael W. Carter

COMMENTS ON EXAMINER'S STATEMENT OF REASONS FOR ALLOWANCE

MS Issue Fee
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Applicant has received the Examiner's Statement of Reasons for Allowance with the Notices of Allowance and Allowability of January 28, 2010, in connection with the above-identified application. The Examiner therein provided a Statement of Reasons for Allowance regarding the claims.

In that regard, Applicant does not acquiesce to any inference or presumption that may be drawn from the Examiner's stated reasoning, and the issuance of the Examiner's Statement of Reasons for Allowance should not be construed as surrender by Applicant of any subject matter.

Dated: April 14, 2010

Respectfully submitted,

By 

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